



RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2879

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: SIT-0107

Inventors: Becker et al.

Serial No.: 09/876,238

Filing Date: June 7, 2001

Examiner: Harper, Holly R.

Group Art Unit: 2879

Title: A Monochromatic Vacuum Ultraviolet Light
Source for Photolithography Applications
Based on a High-Pressure Microhollow
Cathode Discharge

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REPLY UNDER 37 C.F.R. § 1.116

This is in response to the Office Action mailed June 4, 2003,
setting a three (3) month statutory period for reply. Please enter
the following amendments and remarks into the record.

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